



Docket No.: M4065.0139/P139-A  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Cem Basceri

Confirmation No.: 2413

Application No.: 09/633,132

Group Art Unit: 2815

Filed: August 4, 2000

Examiner: E. Lee

For: METHOD FOR IMPROVING THE  
SIDEWALL STOICHIOMETRY OF THIN  
FILM CAPACITORS

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

MS: AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 11, 2003 (Paper No. 22), finally rejecting claims 39, 41-48, 50-56 and 74-83, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks** begin on page 8 of this paper.

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